



500.41374CX2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): S. KANNO, et al
Serial No.: 10/658,281
Filed: September 10, 2003
For: WAFER STAGE FOR PROCESSING APPARATUS AND
WAFER PROCESSING METHOD
Group:
Examiner:

FURTHER PRELIMINARY AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 9, 2003

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Specification;

Amendment of the Claims; and

Remarks are included following the amendments.